

In the Specification:

On page 1, please change the title of the invention as follows:

METHODS OF CHEMICAL VAPOR DEPOSITION AND POWDER FORMATION USING THERMAL SPRAY WITH NEAR SUPERCRITICAL FLUID SOLUTIONS

On page 1, please change the paragraph in lines 9-11 to read:

This application is a continuation of United States Patent Application Serial No. 09/293,867 (now abandoned), which is a continuation of United States Patent Application Serial No. 08/691,853 (now U.S. Patent No. 5,997,956) which is a continuation-in-part of Applicant's copending United States Provisional Application Serial No. 60/002,084, filed August 4, 1995, the contents of all of which are hereby incorporated in their entirety by this reference.